



03500.017972.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: A.D. Diamond
KOICHI MATSUDA ET AL.)
: Art Unit: 1753
Application No.: 10/807,103)
:
Filed: March 24, 2004)
:
For: STACKED PHOTOVOLTAIC)
ELEMENT AND METHOD :
FOR PRODUCING THE SAME) August 2, 2005

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

INFORMATION DISCLOSURE STATEMENT

Sir:

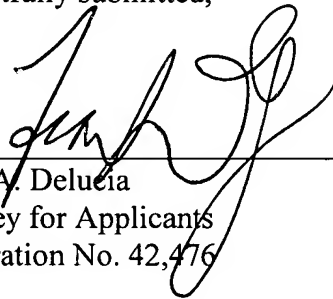
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the attached English translation of the publication by Yamamoto, Kenji, entitled "Thin-film polycrystalline Silicon Solar Cell", Applied Physics, The Japanese Society of Applied Physics: May 2002, Vol. 71 No. 5, pp. 522-527, which was listed on the Form PTO-1449 enclosed with the Information Disclosure Statement filed April 19, 2005. The Examiner's attention is also directed to the attached copy of the mentioned publication, in which text shown in the drawing has been translated into English, as shown in handwriting. The attached Form

PTO-1449 lists the English translation and the publication with handwriting.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

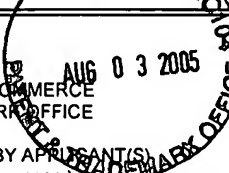
Respectfully submitted,



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NY_MAIN481893v1

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. 03500.017972		APPLICATION NO. 10/807,103			
							
APPLICANT KOICHI MATSUDA ET AL.							
FILING DATE March 24, 2004				GROUP 1753			
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		K. Yamamoto, "Thin-film Polycrystalline Silicon Solar Cell", Applied Physics, The Japan Society of Applied Physics, May, 2002, vol. 71, No. 5, pgs. 522-527 (English translation)					
		K. Yamamoto, "Thin-film Polycrystalline Silicon Solar Cell", Applied Physics, The Japan Society of Applied Physics, May, 2002, vol. 71, No. 5, pgs. 522-527 (with handwritten English translation of text shown in drawings)					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.